

COPY

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Hirotooshi KUBO : Docket No. 01213/GSY986-US
Serial No. 09/517,698 : Group Art Unit 2814
Filed March 2, 2000 : Examiner N. Ngo
SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREOF :

11046 U.S. PTO
09/919797
08/02/01

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

PETITION FOR EXTENSION OF TIME AND EXPRESS ABANDONMENT

Assistant Commissioner for Patents,
Washington, DC 20231

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of February 16, 2001.

The fee of \$890.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

() Small entity status of this application is established by the verified statement under 37 CFR 1.9 and 1.27 which

() is enclosed.

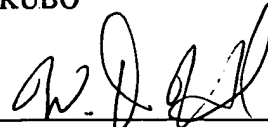
() has been previously submitted.

This Petition is for the purpose of concurrently filing a divisional application in place of the above-identified application. Accordingly, the above-identified application is hereby expressly abandoned, conditioned upon the granting of this Petition and the granting of a filing date to said continuing application.

Respectfully submitted,

Hirotooshi KUBO

By:


W. Douglas Hahn
Registration No. 44,142
Attorney for Applicant

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August 2, 2001